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Docket No.: 0756-2409

2881

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT application of)

Koichiro TANAKA)

Serial No. 10/021,719)

Group Art Unit: 2881

Filed: December 19, 2001)

Examiner: Unassigned

For: LASER ANNEALING METHOD AND)

SEMICONDUCTOR DEVICE FABRICATION)

METHOD

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with The United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P. O. Box 1450, Alexandria VA 22313-1450, on March 3, 2004

Benny D. Quast

SECOND REQUEST FOR STATUS

Honorable Commissioner of Patents

P. O. Box 1450

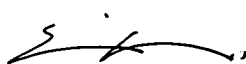
Alexandria VA 22313-1450

Sir:

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MAR 09 2004

To date the undersigned attorney of record has received no action in the above-identified patent application. Please provide the undersigned with a status report of the application in writing.

Respectfully submitted,


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